

PATENT ASSIGNMENT

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CONVEYING PARTY DATA	
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RECEIVING PARTY DATA	
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OFFICE OF TECHNOLOGY
COMMERCIALIZATION

Application for: Layer stripping process for impedance imaging

Inventor(s): Margaret Cheney, David Isaacson, Erkki Somersalo, Eli L. Isaacson

Serial No.: 07/727,075

Date Filed: 07/09/1991

Institution Case No.: 357c

Contract No.: 8706340, GM39388, GM42935

Contractor: Rensselaer Polytechnic Institute


The invention identified above is a "Subject Invention" under Patent Rights clause included in Contract Number 8706340, GM39388, GM42935 with the National Science Foundation and National Institute of Health.

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Signed this 3rd day of May, 2005.

UNIVERSITY

By 
Signature and Title

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